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In re Applicant:	Achintya K. Bhowmik	§	Art Unit:	2873
Serial No.:	10/814,402	§	Examiner:	Jessica T. Stultz
Filed:	March 31, 2004	§	Docket:	ITL.1099US P18549
For:	Single Crystal Electro-Optic Film on Silicon Imager	§	Assignee:	Intel Corporation

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REPLY TO FINAL REJECTION**

Sir:

In response to the final rejection mailed November 8, 2006, reconsideration is requested in view of the following remarks.

A current listing of the claims is attached. No amendments were made.

Date of Deposit: November 28, 2006  
I hereby certify that this document is being facsimile transmitted to the United States Patent and Trademark Office (Fax No. 571/273-8300) on the date indicated above.  
*Cynthia L. Hayden*  
Cynthia L. Hayden